PATENT Customer No. 22,852 Attorney Docket No. 8071.0007

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	) \
Takeshi MITSUISHI et al.	) Group Art Unit: 2872
Application No.: 09/986,907	) Examiner: Joshua Pritchett
Filed: November 13, 2001	) )
For: COMPOSITION FOR VAPOR DEPOSITION, METHOD FOR FORMING AN ANTIREFLECTION FILM AND OPTICAL FLEMENT	) Confirmation No.: 6647 ) )

Mail Stop RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a three-month extension of time to file a response.

A Notice of Appeal was filed on September 7, 2004. A fee of \$1,020.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

02/08/2005 SDENBOB1 00000039 09986907

Respectfully submitted,

01 FC:1801 02 FC:1801 03 FC:1202 04 FC:1253 790.00 0p 400.00 0p 980.00 0p 1020.00 0p

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: February 7, 2005

Charles E. Van Horn Reg. No. 40,266